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U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

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FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TD	A	SPIE Handbook of Microlithography, Micromachining and Microfabrication, Vol. 1: Microlithography [online], [retrieved on 2001-11-29] Retreived from <URL: http://www.cnf.cornell.edu/SPIEBook/spie9.htm
TD	B	Operations Manual for Model F5, KLA-Tencor Corp., Chapters 3, 4: Creating and Editing Recipes, Manual: 04-0452A, Dec. 1998, pp. 3-1 to 4-44
TD	C	Operations Manual for Model AIT, KLA-Tencor Corp., Chapters 4,5: Creating Recipes, #530131-36 Rev. A 4/99, pp. 77-144

EXAMINER Umemoto DATE CONSIDERED 4-1-03

EXAMINER: Initial if references considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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